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DEC 17 2004
PATENT & TRADEMARK OFFICE

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 016907-1578

In re patent application of

Eiji MORIFUJI

Serial No.: 10/677,858 Group Art Unit: 2814

Filed: October 3, 2003 Examiner: Ngan V. Ngo

For: SEMICONDUCTOR APPARATUS AND METHOD FOR MANUFACTURING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 19, 2004, Applicant hereby elects the claims of Group I, claims 1-13, drawn to a semiconductor device, for prosecution in the subject application.

Upon allowance of the elected claims, Applicant will be permitted to request rejoinder in accordance with MPEP 821.04 and *In re Ochiai*, 71 F.3d 1565 USPQ2d 1127 (Fed.Cir. 1995) of method claims 14-18.

Receipt of the initial Office Action on the merits is awaited.

Respectfully submitted,

Date: DEC 17 2004

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